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**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 2123**

**PATENT**  
Customer No. 22,852  
Attorney Docket No. 4329.2612-00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
Ryoichi Inanami et al. ) Group Art Unit: 2123  
Application No.: 09/912,398 ) Examiner: Stevens, Thomas H.  
Filed: July 26, 2001 )  
For: METHOD AND SYSTEM FOR ) Confirmation No.: 5029  
PRODUCING SEMICONDUCTOR )  
DEVICES ) **Mail Stop AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER FINAL**

In response to the final Office Action dated June 30, 2005, the period for response to which extends through September 30, 2005, and pursuant to 37 C.F.R. § 1.116, Applicants propose to amend this application as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks/Arguments** follow the amendment sections of this paper.

**Attachments** to this amendment include an English language translation of Japanese Patent Application No. 2000-227324, filed in Japan on July 27, 2000.